

Characterisation of optical elements for soft X-ray microprobing and microscopy

Matthew Shand

Silson Ltd.

(King's College London)

Talk outline

Experimental outline

- Microfocus X-ray source description

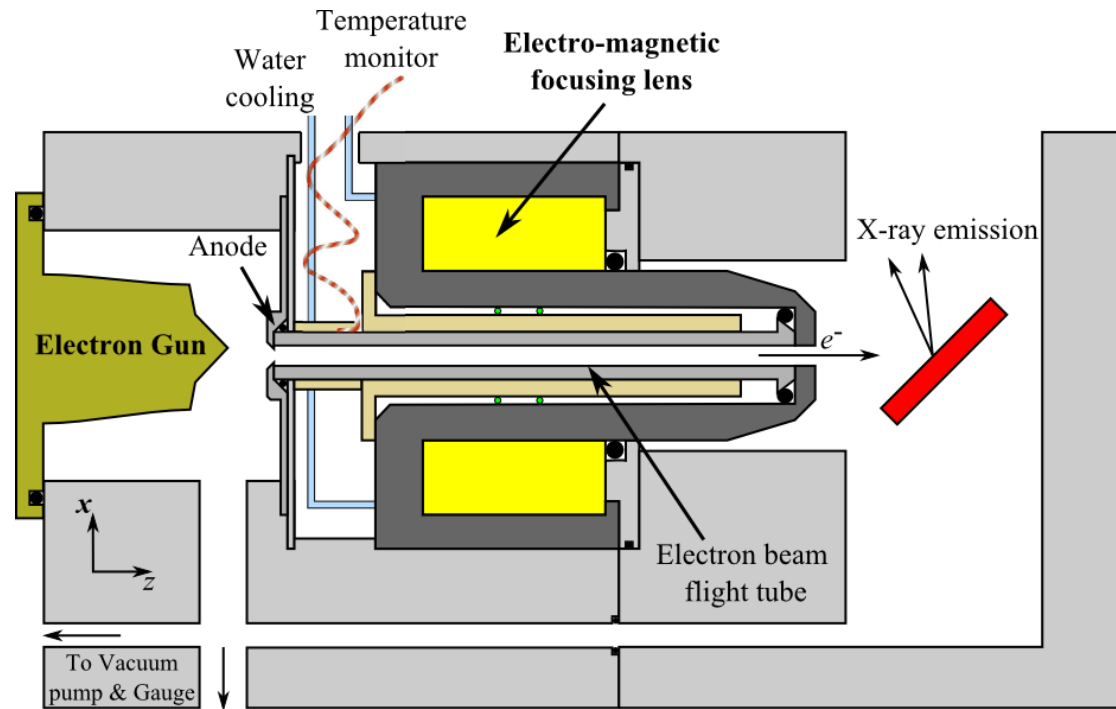
Microprobing

- Microstructured Optical Arrays (MOAs)
- Optical Characterisation

Microscopy

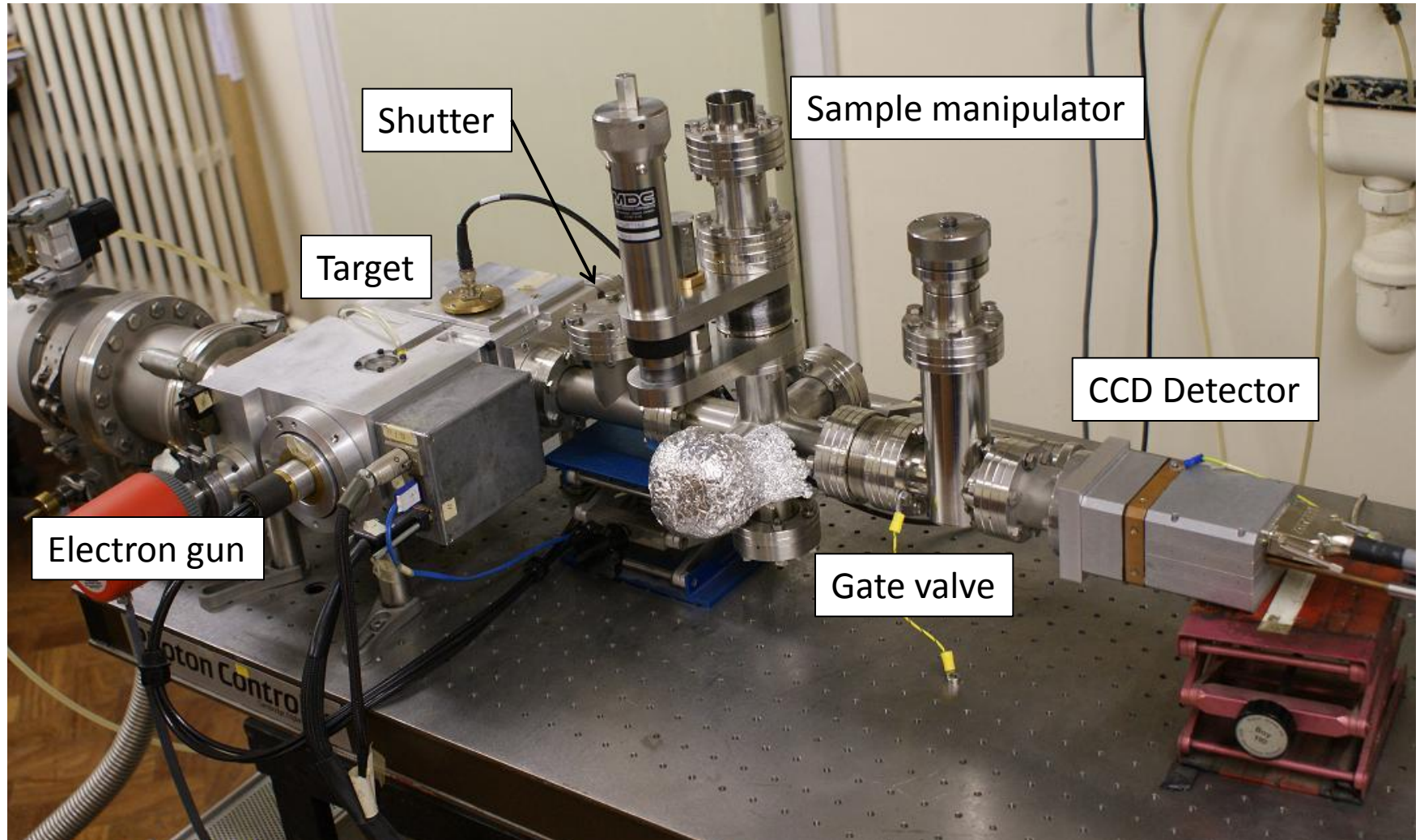
- **Microscope X-ray In-vitro (McXI)**
- Zone plates
- Characterisation results

The microfocus soft X-ray source

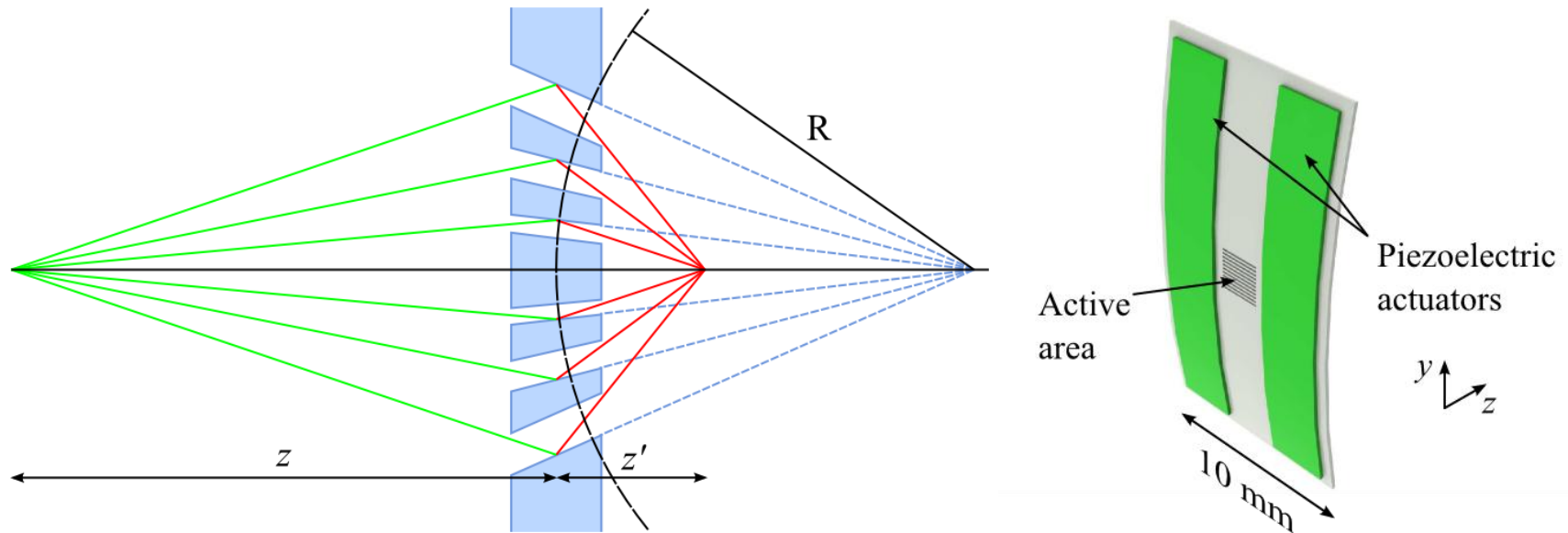


- Electron bombardment X-ray source
- Interchangeable target materials Al ($K_{\alpha}=1.477$ keV), C ($K=0.277$ keV)
- ≈ 200 μm diameter X-ray source

Microfocus source coupled to detector



Microstructured Optical Array (MOA)

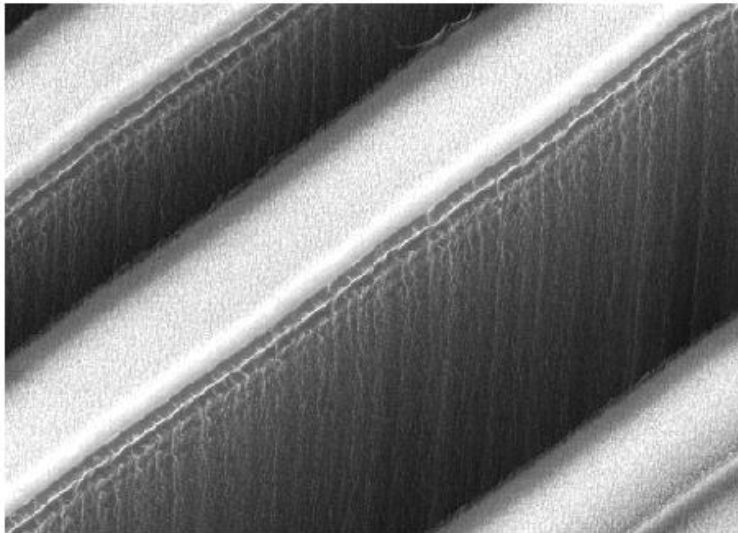


- Developed as part of the Smart X-ray Optics consortium
- Reflections from an array of channels contribute to focused spot
- Single and double reflections considered along X-ray path
- Active control of focal length
- Radiobiological microprobe experiments (2 μm diameter focused spot of Ti K_{α} X-rays from a 5 μm X-ray source)

Manufacture of MOAs

DRIE

(Bosch Process)

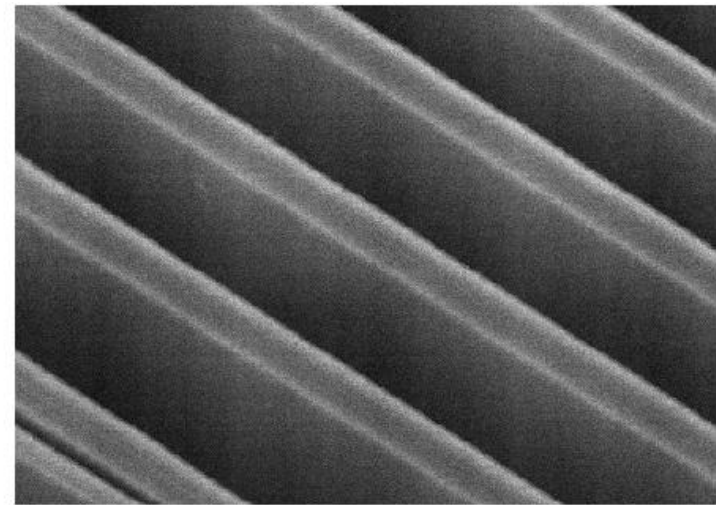


20 μm

Roughness ≈ 8 nm RMS
(min.)

TMAH

(Alkaline solution)

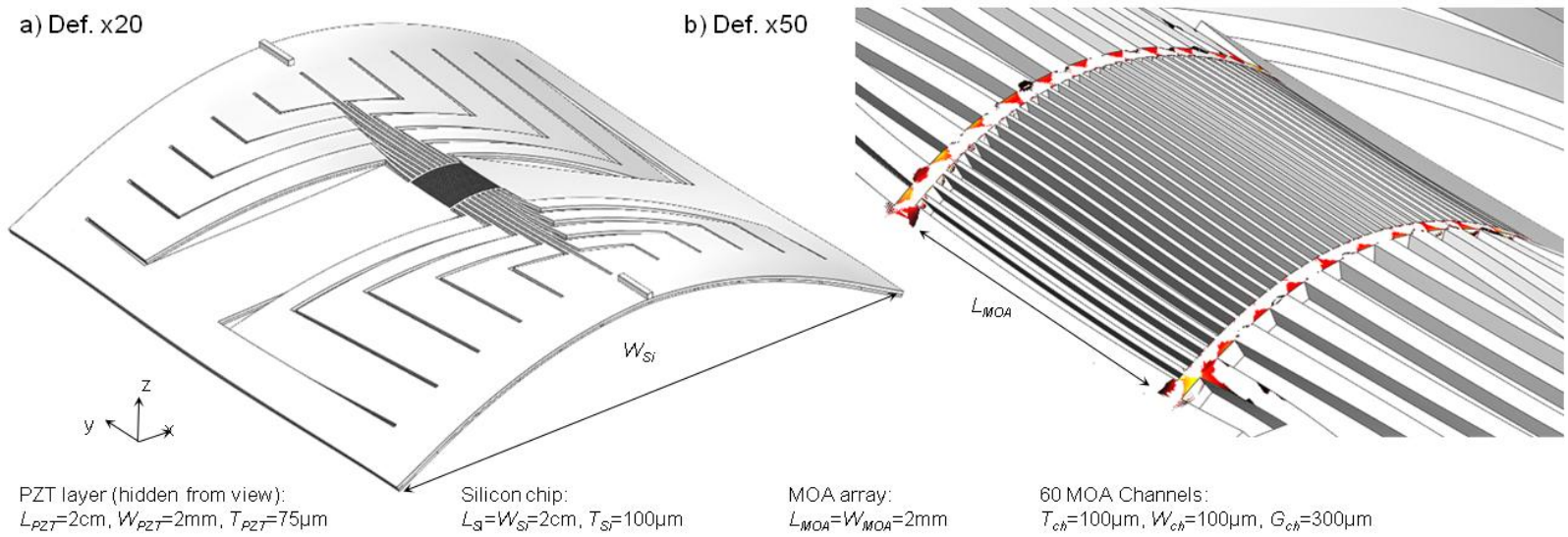


70 μm

Roughness ≈ 1.5 nm RMS

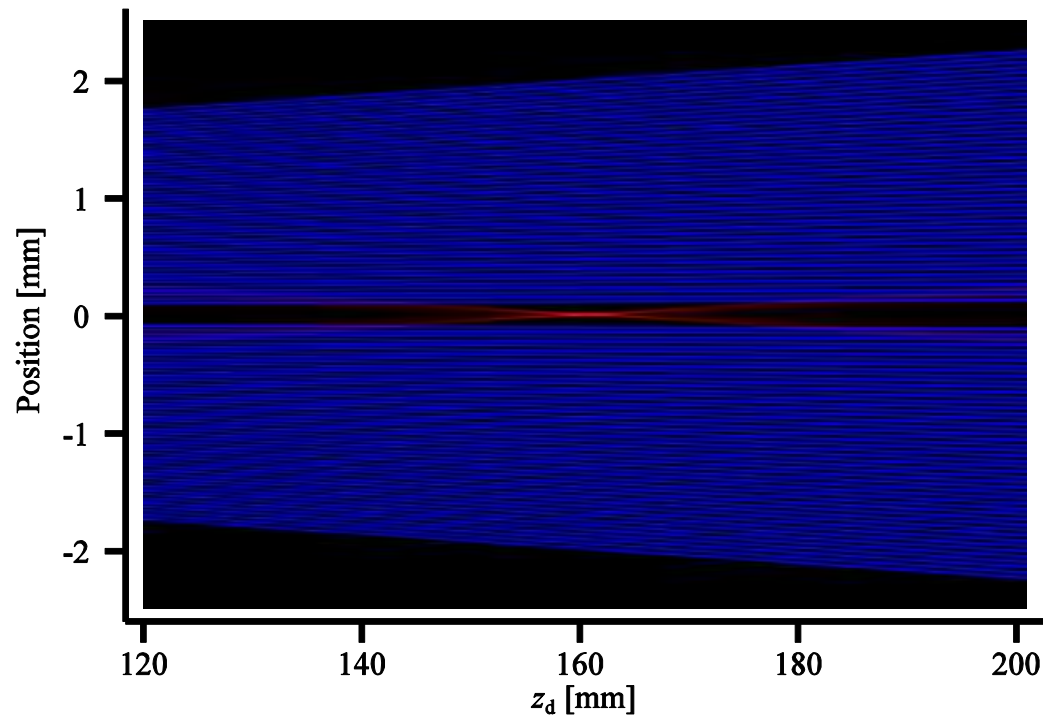
Spider MOAs

- For an appropriate focal length, $R \approx 50$ mm
 - Not achievable using simple designs ($R = 420$ mm min.)
- Spider-like levers etched into silicon substrate enhance the curvature across the active area
- Mechanical testing of spider MOAs indicates $R=30$ mm

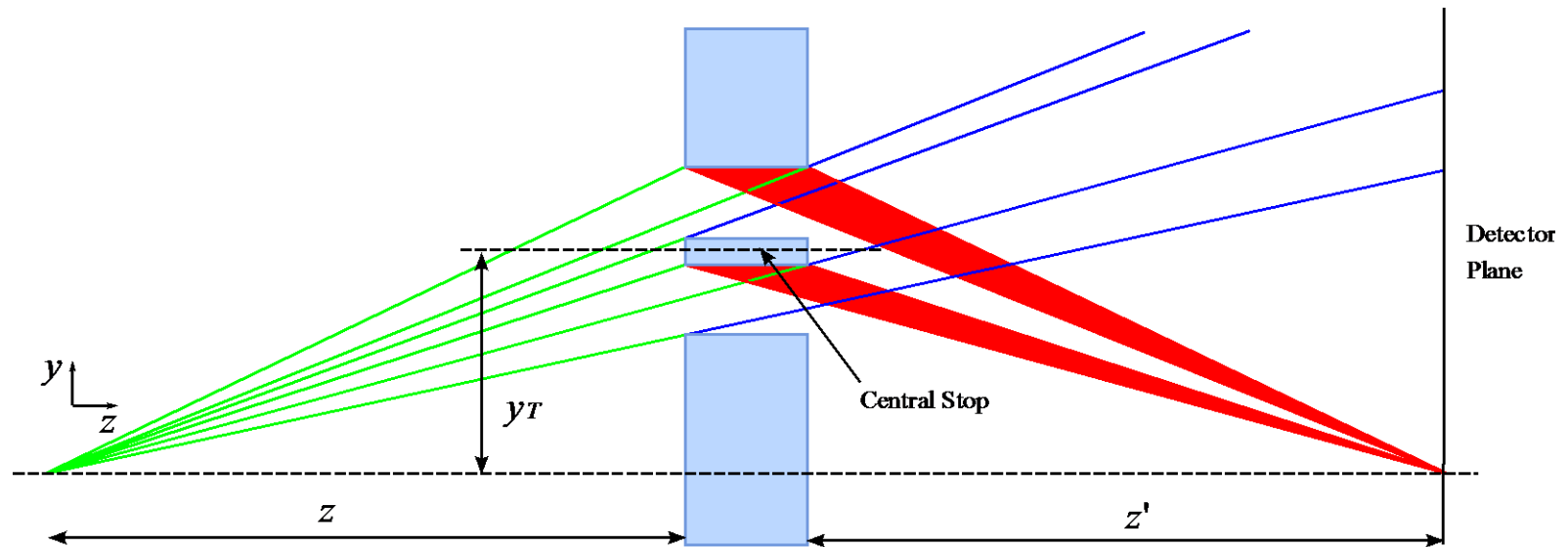


Simulation of MOA focusing properties

- Simulation of focusing effect for a MOA array
- X-rays reflected (red pixels) by each channel contribute to a common focused spot at $z_d=z=160$ mm
- Focused spot is isolated from unreflected (blue) X-rays by central stop

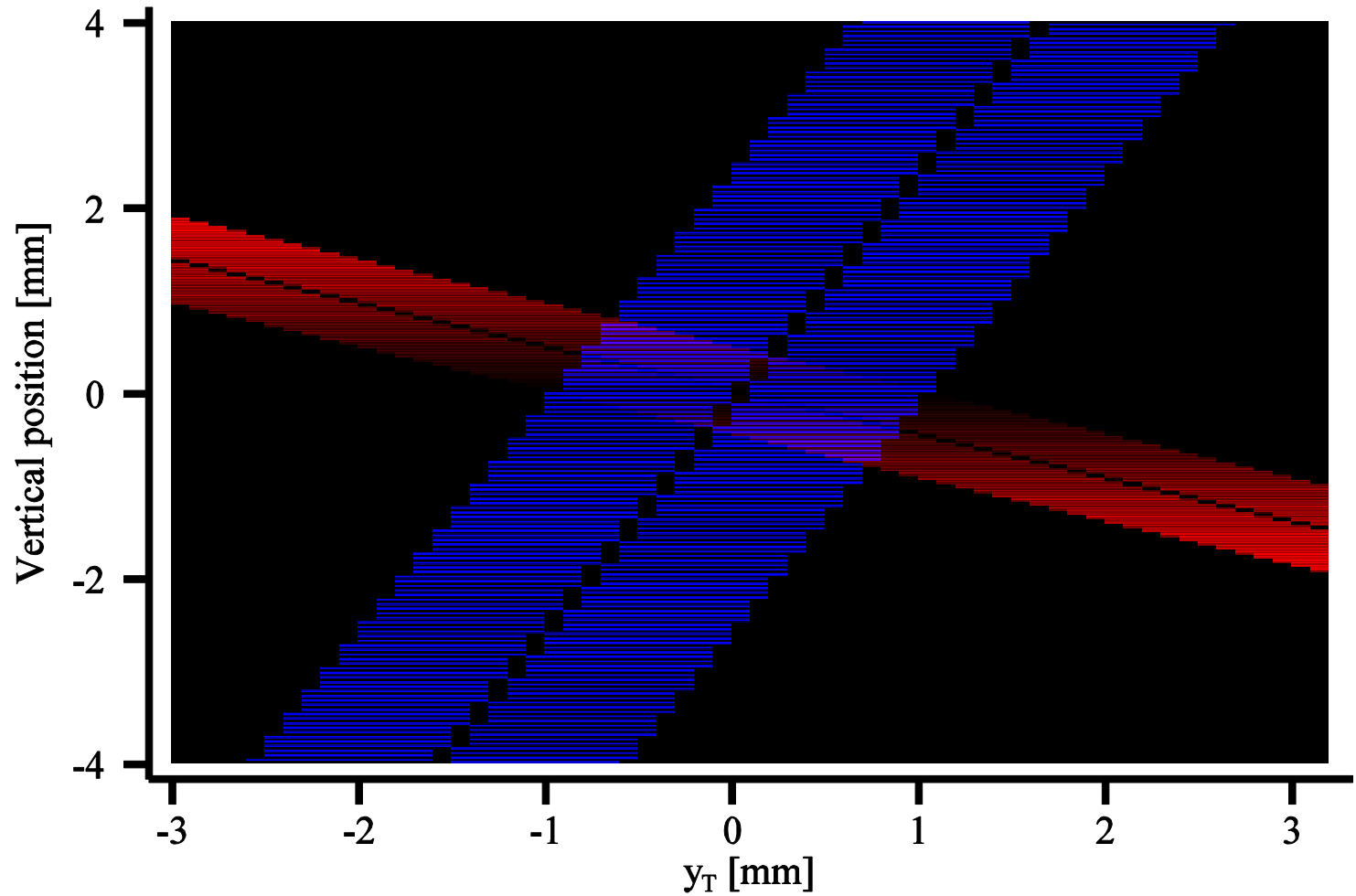


Experimental method for characterisation of MOAs

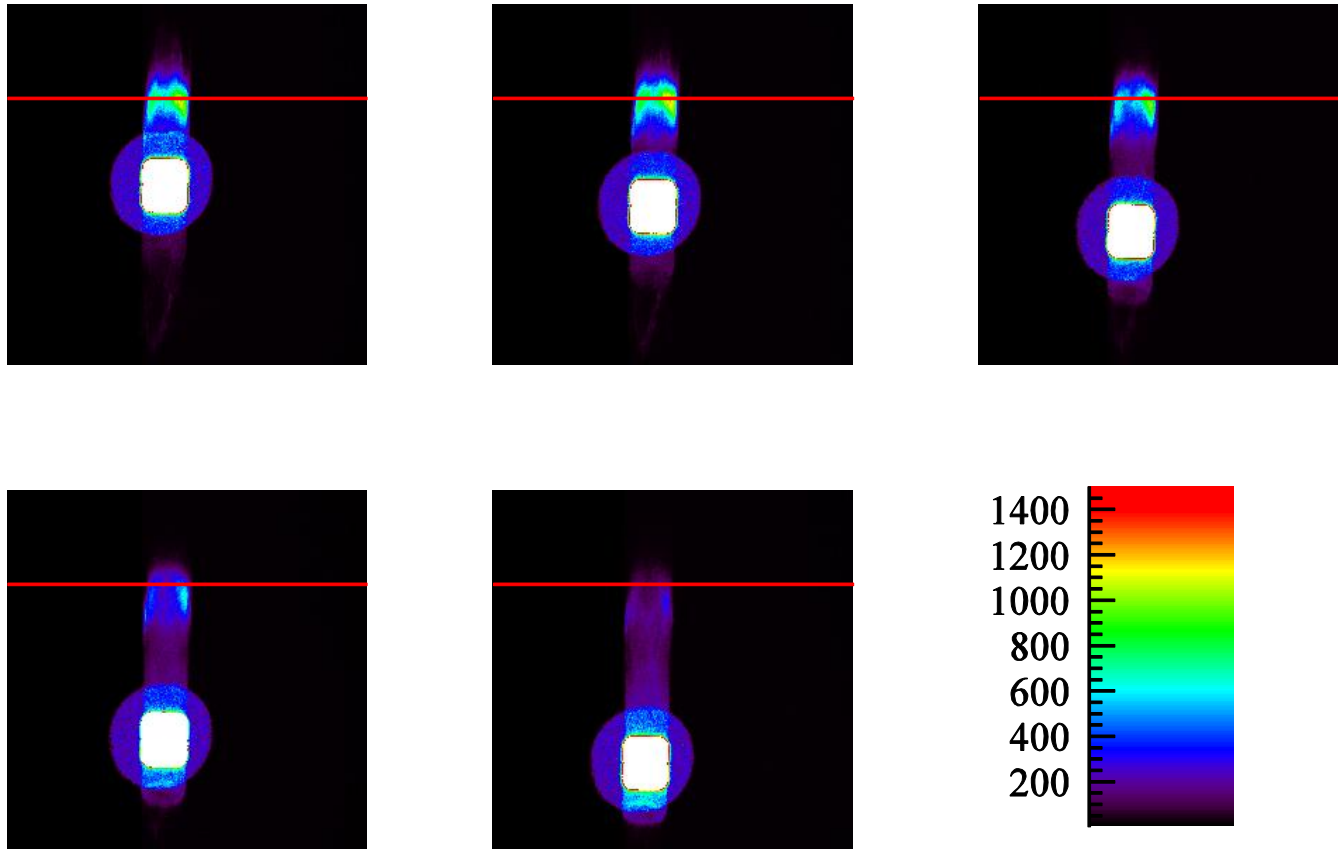


- Displacement of MOA channels from optical axis separates reflected radiation from unreflected “background”
- Ideal for use with microfocus X-ray source.

Simulation of MOA displacement (y_T)

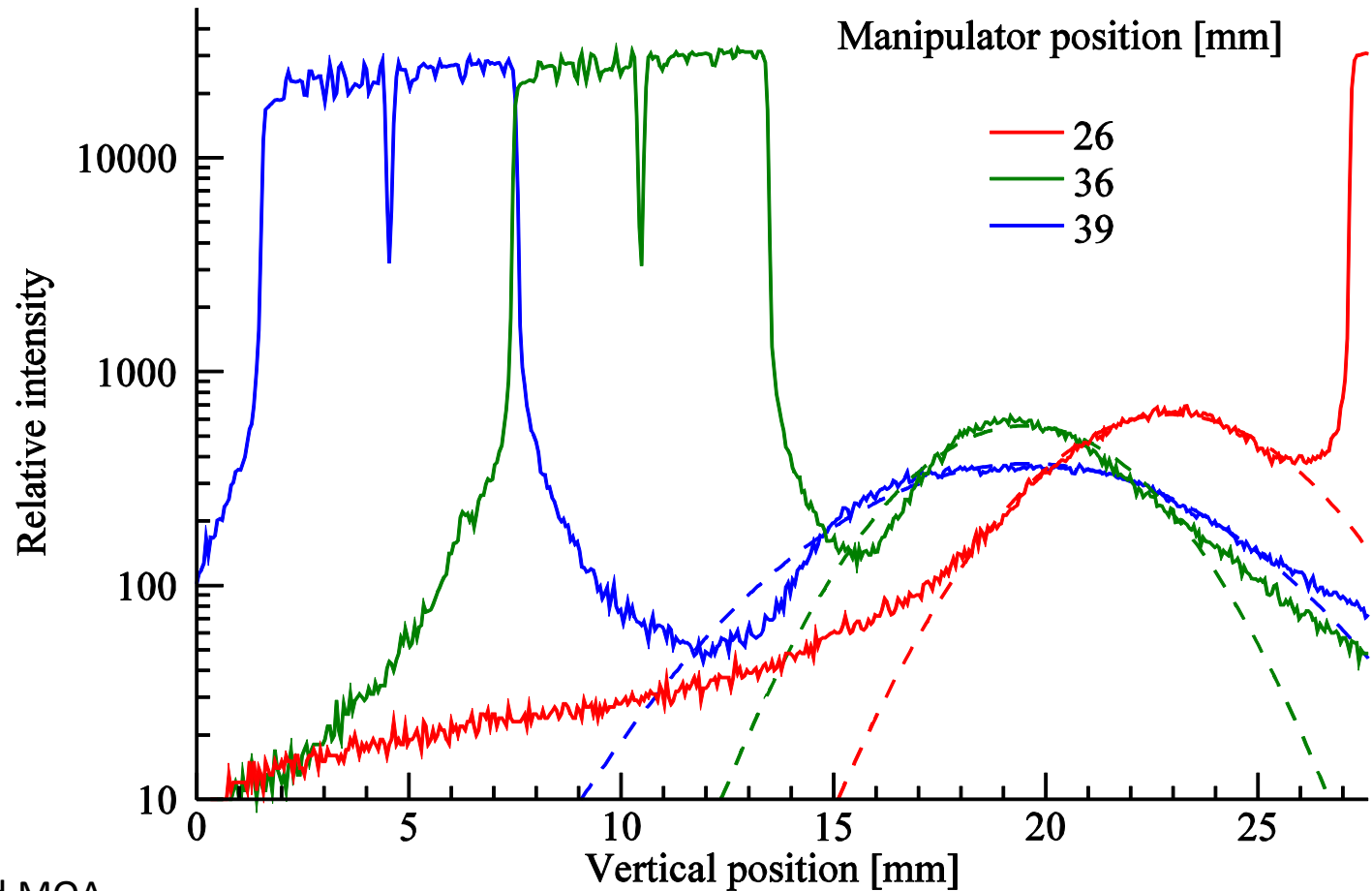


Experimental characterisation of MOAs



TMAH etched MOA
Broadband Al X-rays
 $z=z'=300$ mm

Experimental characterisation of MOAs

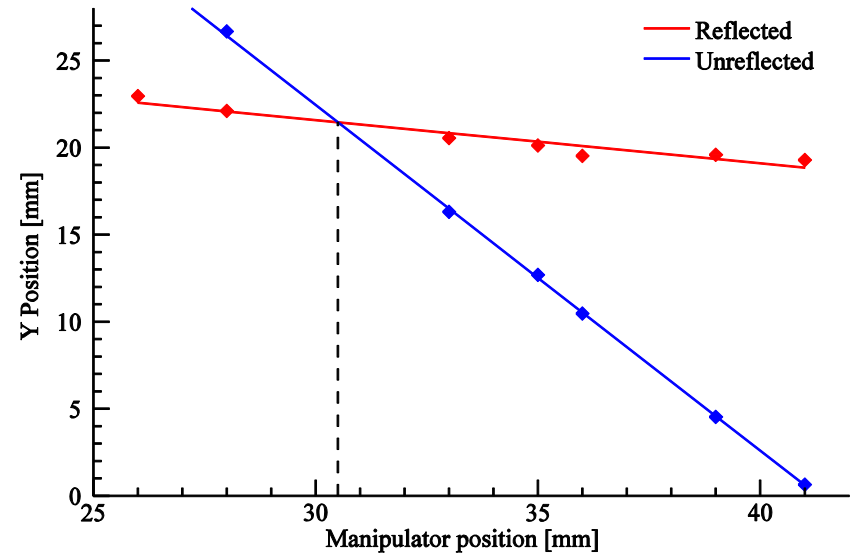
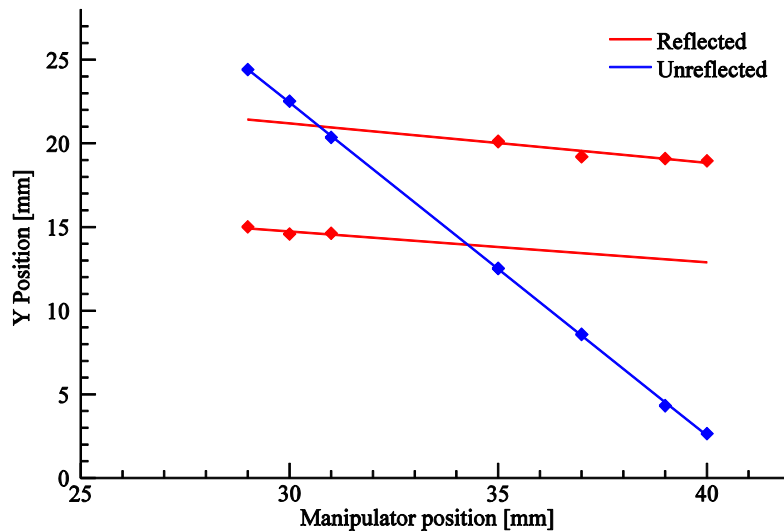


DRIE etched MOA
Broadband Al X-rays
 $z=z'=300$ mm

Position stability of DRIE vs TMAH

DRIE etched MOA

- Symmetrical about either side of optical axis



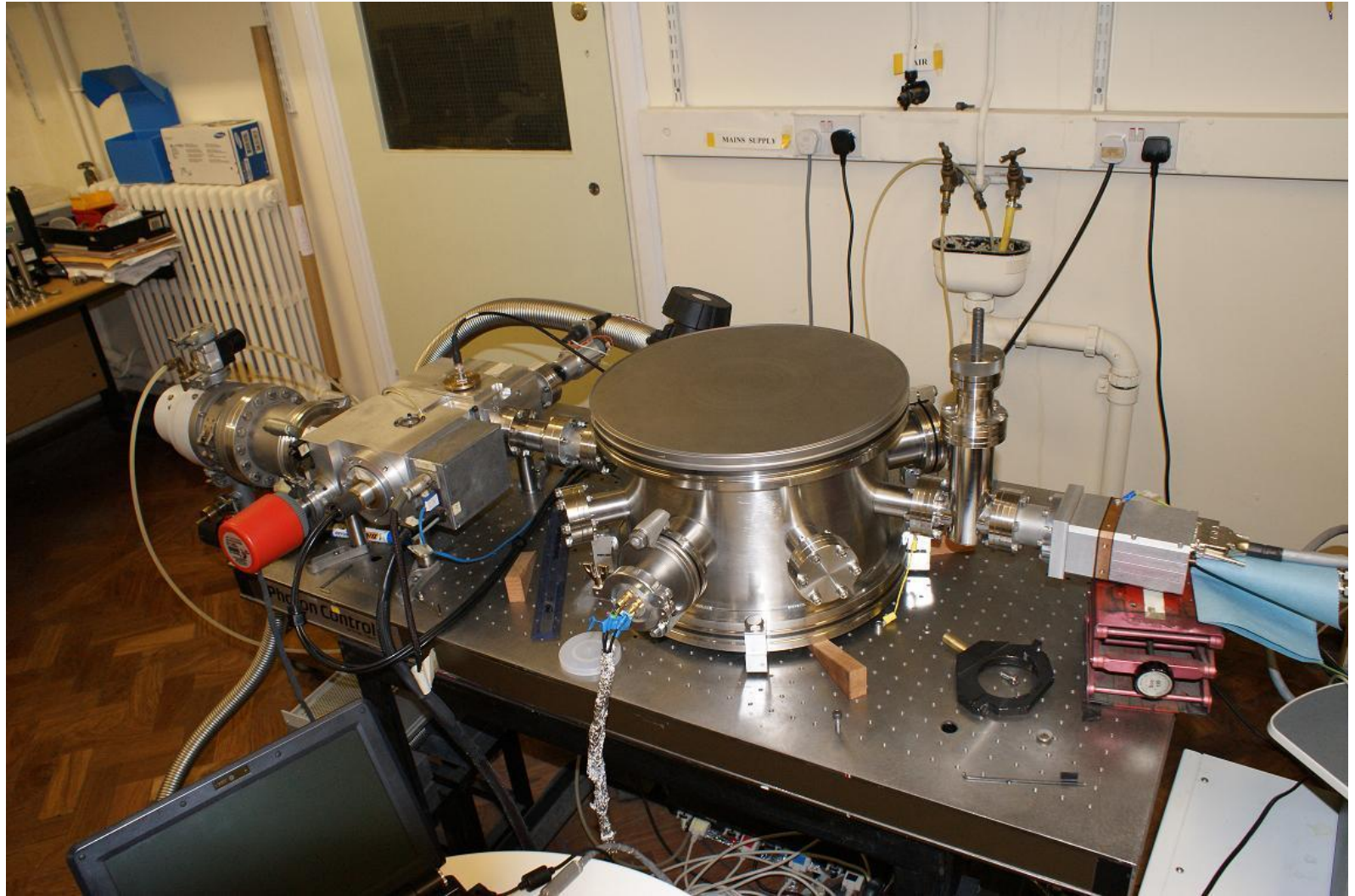
TMAH etched MOA

- Shift in reflected position occurs due to taper in channel structure

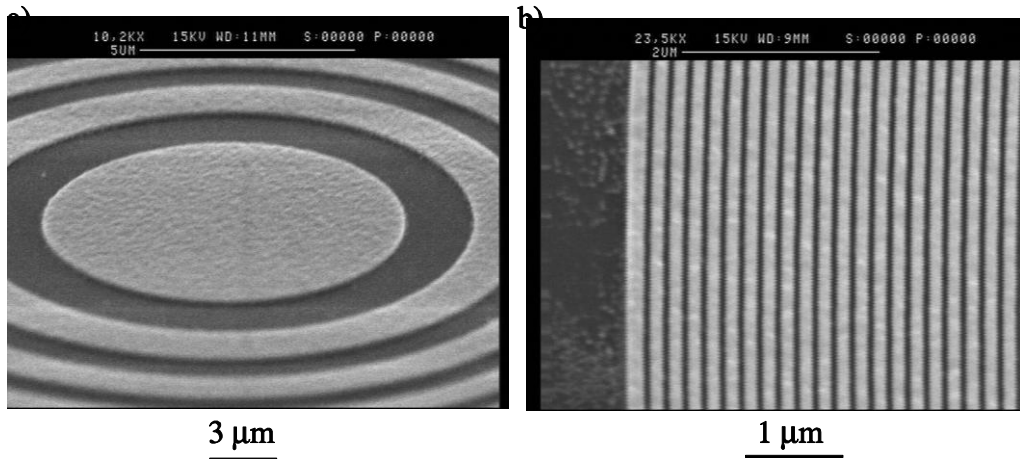
STSM – Characterisation of a prototype soft X-ray microscope

- Autumn 2009
- Aim: To characterise the performance of the McXI-I (**M**icroscope **X**-ray **I**n-vitro) prototype soft X-ray microscope (www.mcx.eu)
- In collaboration with NANO-UV
- Additional work has since been conducted at KCL, to characterise the microscope using the microfocus X-ray source described

McXI-I microscope

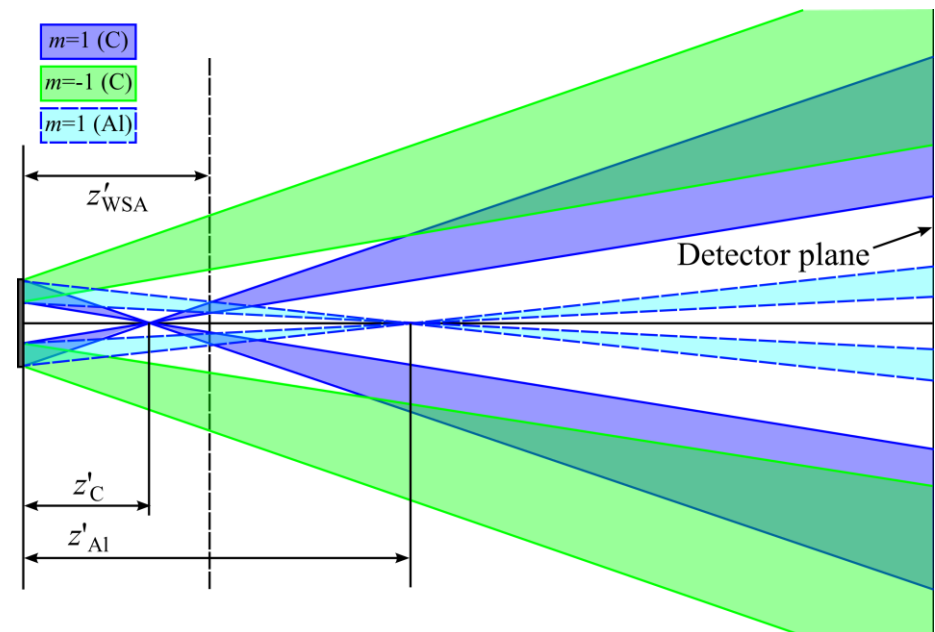


Zone Plate (ZP) characterisation

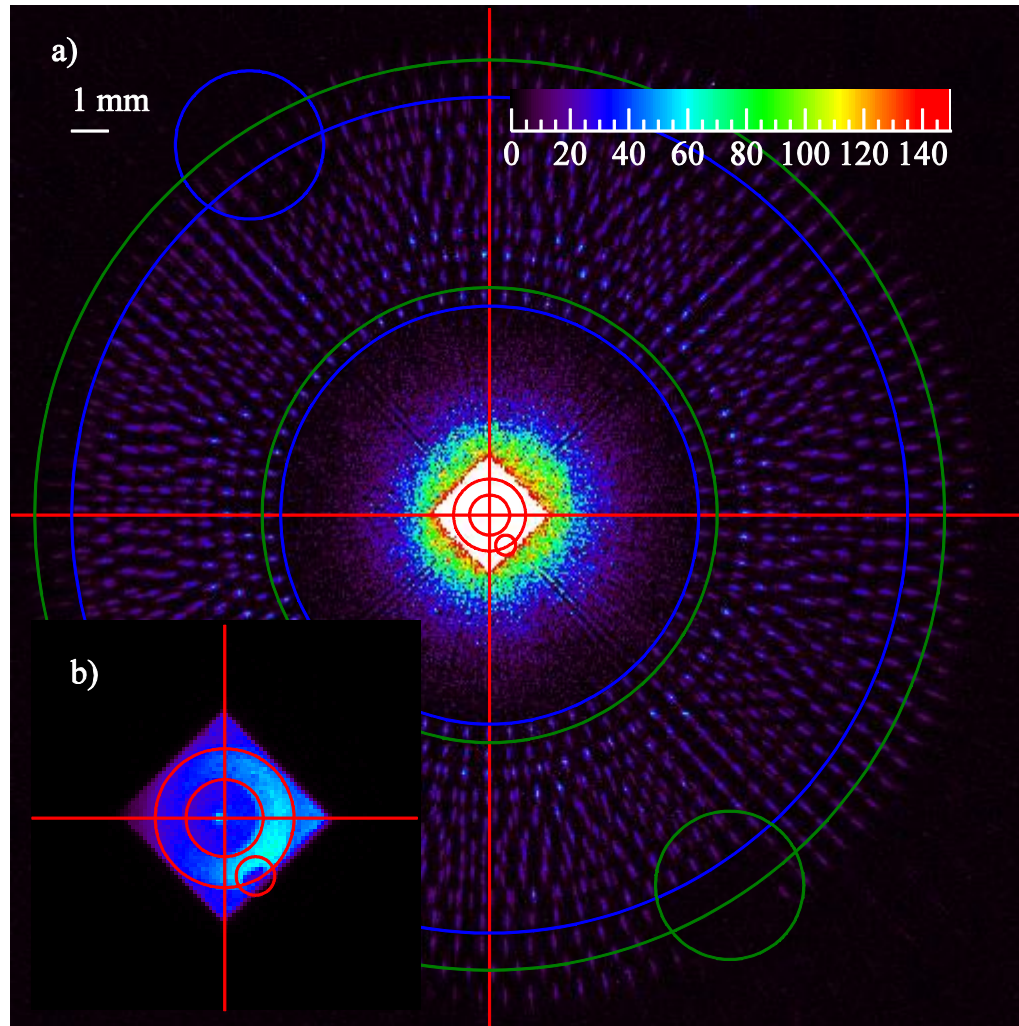


Typical Au electroplated ZP
($d_n=100$ nm)
Silson Ltd.

1st order diffraction pattern
produced by ZP (C, Al)



Diffraction pattern of Condenser ZP



Broadband X-rays produced by C target

Conclusions

- A microfocus X-ray source has been developed at KCL for characterisation of soft X-ray optics
- This source has been used to characterise unactuated MOAs, and shows good comparison with simulation
 - The performance of actuated MOAs may now be considered in a similar manner
- Initial tests of the performance of the McXI-I microscope have also been performed using this X-ray source

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- University College London

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